

**IN THE U. S. PATENT AND TRADEMARK OFFICE**

In re application of

Rikizo HATAKEYAMA et al.

Conf. 6826

Application No. 10/552,709

Group 4181

Filed July 26, 2006

Examiner H. Chan

METHOD AND APPARATUS FOR PRODUCING  
GAS ATOM CONTAINING FULLERENE, AND GAS ATOM  
CONTAINING FULLERENE

**PETITION FOR EXTENSION OF TIME**

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 12, 2009

Sir:

The undersigned hereby petitions for an extension of time to respond to the Official Action of October 16, 2008 for two months to January 16, 2009.

Please charge the extension fee of \$245.00 to our credit card set forth in the attached Credit Card Payment Form.

A responsive paper is filed herewith.

Respectfully submitted,

YOUNG & THOMPSON

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RJP/lk